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In Affiliation with
Weiss, Moy & Harris, PC
having offices in Arizona and Nevada,
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Rabin & Berdo, PC

December 31, 2003

Mail Stop Patent Application

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Attorney Reference: OKI 394

Re: New Patent Application of: Kazuhide ABE

Title: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

Sir:

Please find attached hereto an application for patent which includes:

- ☒ Specification, Claims and Abstract (13 Pages)
- ☒ 3 Sheets of Formal Drawings (Fig. 1 through Fig. 3)
- ☒ Inventor's Declaration and Power of Attorney (3 Pages)
- ☒ Assignment document with cover page (2 Pages)
- ☒ Claim for priority and the Priority document
- ☒ Information Disclosure Statement, Form PTO-1449, and copies of four references
- ☒ Form PTO-2038
- ☒ Fee (see formula below)

Basic Fee \$770/385 \$ 770.00

Additional Fees:

Total number of claims: 8
in excess of 20: 0 times \$18/9 \$ 0.00

Number of independent claims: 2
in excess of 3: 0 times \$86/43 \$ 0.00

Multiple Dependent Claims \$290/145 \$ 0.00

Recording Fee \$40. \$ 40.00

TOTAL FEES FOR THE ABOVE APPLICATION \$ **810.00**

In the event there is attached hereto no credit card form PTO-2038 or check, or there is an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The rights of priority are claimed under 35 USC §119 of Japanese Application No. 2003-113648, filed April 18, 2003.

Respectfully submitted,

Robert H. Berdo, Jr. (Reg. No. 38,075)
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December 31, 2003
Date
RHB:tz

